| Search Notes | | | |
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| Application/Control No. | Applicant(s)/Patent under Reexamination | | |
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| 10/654,168 | DIVERGILIO ET AL. | | |
| Examiner | Art Unit | | |
| Ephrem Alemu | 2821 | | |

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|----------|-------------------------------|-----------|----------|--|
| Class | Subclass | Date | Examiner | |
| 315 | 506, 505, 507, 501, 500 | 2/28/2005 | EA | |
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| Updated | Search | 5/12/2005 | EA | |
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| SEARCH NOT (INCLUDING SEARCH | |) |
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| | DATE | EXMR |
| Searched EAST Search Terms: Quadrupole lens electrode ion implantation undulator voltage supply unipolar bipolar switching | 2/28/2005 | EA |
| EAST | 5/12/2005 | EA |
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